



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

November 24, 2025

IGI Report Number **LG751514307**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **PRINCESS CUT**

Measurements **7.81 X 7.75 X 5.57 MM**

GRADING RESULTS

Carat Weight **3.04 CARATS**

Color Grade **F**

Clarity Grade **VVS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

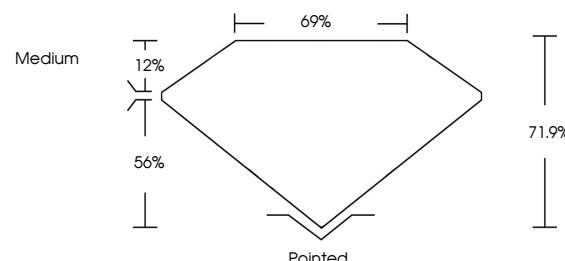
Symmetry **EXCELLENT**

Fluorescence **NONE**

Inscription(s) **IGI LG751514307**

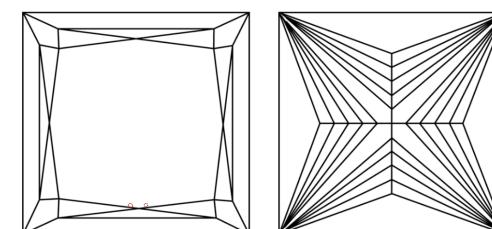
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

www.igi.org

LG751514307
Report verification at igi.org

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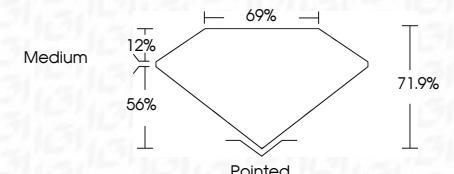
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November 24, 2025	IGI Report No. LG751514307
PRINCESS CUT	
7.81 X 7.75 X 5.57 MM	
Carat Weight	3.04 CARATS
Color Grade	F
Clarity Grade	VVS 2
Depth	71.9%
Table Grade	69%
Culet	Medium
Polish	Pointed
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	IGI LG751514307

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Type IIa